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FACSIMILE COVER SHEET

TO: Examiner William T. Leader
U. S. Patent & Trademark Office
Group Art Unit 1742

FROM: Damond E. Vadnais, Reg. No. 52,310

RE: U.S. Application No. 10/805,323 Atty. Docket No.: 03500.017969.

FAX NO.: (571) 273-8300

**DATE:** January 8, 2007

NO. OF PAGES:

(including cover page)

TIME: 4/22 P.M.

SENT BY:

### **MESSAGE**

#### Attachments:

Amendment and Response to Restriction Requirement Transmittal Amendment and Response to Restriction Requirement

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January 8, 2007 Date

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Damond E. Vadnais, Reg. No. 52,310 Name of person signing certificate

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In re Application of:

Docket No. 03500.017969.

MASUMITSU IWATA, ct al.

Application No.: 10/805,323

Examiner: William T. Leader

Filed: March 22, 2004

Group Art Unit: 1742

Date: January 8, 2007

For: ZINC OXIDE FILM TREATMENT METHOD

AND METHOD OF MANUFACTURING

PHOTOVOLTAIC DEVICE UTILIZING THE SAME

Mail Stop Amendment THE COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an Amendment and Response to Restriction Requirement in the above-identified application.

X No additional fee is required.

The fee has been calculated as shown below

CLAIMS AS AMENDED							
	(2) CLAIMS REMAINING AFTER AMENDMENT		(4) HIGHEST NO. PREVIOUSLY PAID FOR	(5) PRESENT EXTRA	RATE	ADDITIONAL FEE	
TOTAL CLAIMS	* 7	MINUS	** 20	0	x \$25 \$50	\$0 <u>-</u>	
INDEP. CLAIMS	* 1	MINUS	***	= 0	x \$100 \$200	\$0	
Fee for Mu	\$0						
	. \$0						

\* If the entry in Column 2 is less than the entry in Column 4, write "0" in Column 5.

\*\* If the "Highest Number Previously Paid For" IN THIS SPACE is less than 20, write "20" in this space.

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Page 1 of 2

	Verified Statement claiming small entity status is enclosed, if not filed previously.				
	A check in the amount of \$ is enclosed.				
	Charge \$ to Deposit Account No. 06-1205. A duplicate copy of this sheet is enclosed.				
X	Any prior general authorization to charge an issue fee under 37 C.F.R. 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205.				
	A check in the amount of \$ to cover the fee for a month extension is enclosed.				
	A check in the amount of \$ to cover the Information Disclosure Statement fee is enclosed.				
X	Applicants' undersigned attorney may be reached in our Costa Mesa, California office by telephone at (714) 540-8700. All correspondence should continue to be directed to our address given below.				
	Respectfully submitted,				
	Damond E. Vadnais Attorney for Applicants Registration No.: 52,310				

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza New York, New York 10112-3800 Facsimile: (212) 218-2200

Form #120

CA\_MAIN 125/70v1

03500.017969.

PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re A	pplication of:	)	
		:	Examiner: William T. Leader
MASU	JMITSU IWATA, et al.	)	
		:	Group Art Unit: 1742
Applic	ation No.: 10/805,323	)	
		:	
Filed:	March 22, 2004	)	
		:	
For:	ZINC OXIDE FILM TREATMENT	Γ)	
	METHOD AND METHOD OF	:	
	MANUFACTURING	)	
	PHOTOVOLTAIC DEVICE	:	
	UTILIZING THE SAME	)	January 8, 2007
Mail S	top Amendment		
<u></u>	ii fr- Detente		

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

# AMENDMENT AND RESPONSE TO RESTRICTION REQUIREMENT

Sir:

In response to the Office Action dated December 12, 2006, please amend the above-identified application as follows:

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January 8, 2007

Date

Signature

<u>Damond E. Vadnais, Reg. No. 52,310</u> Name of person signing certificate